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Honeywell's Docket No. H0001743 (4780)  
Practitioner's Docket No. 51-017-001

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Box Non-Fee Amendment  
Assistant Commissioner for Patents  
Washington, D.C. 20231**

**POWER OF ATTORNEY BY ASSIGNEE OF ENTIRE INTEREST  
(REVOCATION OF PRIOR POWERS)**

As assignee of record of the entire interest of the above identified application,

**REVOCATION OF PRIOR POWERS OF ATTORNEY**

all powers of attorney previously given are hereby revoked and

**NEW POWER OF ATTORNEY**

the following practitioner is hereby appointed to prosecute and transact all business in the Patent and Trademark Office connected therewith.

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Melanie Brown, Registration No. 31592  
Curtis Brueske, Registration No. 33839  
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| Application No.  | Filing Date | Title  | Reel/Frame No. | Status  |
|------------------|-------------|--|----------------|---------|
| 09/741634        | 12/19/2000  | ELK Dielectric Materials With Layered Structure                              | 011404/0606    | Pending |
| 09/860993        | 05/17/2001  | Hardmask for Electronic Applications   | 011838/0670    | Pending |
| 09/545058        | 04/07/2000  | Low Dielectric Constant Organic Dielectrics Based on Cage-Like Structures    | 010725/0813    | Issued  |
| 09/902924        | 07/10/2001  | Low Dielectric Constant Organic Dielectrics Based on Cage-Like Structures    | 010725/0813    | Pending |
| 10/293024        | 11/12/2002  | Low Dielectric Constant Organic Dielectrics Based on Cage-Like Structures    | 010725/0813    | Pending |
| 09/618945        | 07/19/2000  | Compositions and Methods for Thermosetting Molecules in Organic Compositions | 011294/0174    | Issued  |
| 10/176335        | 06/19/2002  | Compositions and Methods for Thermosetting Molecules in Organic Compositions | 011294/0174    | Pending |
| 10/267380        | 10/08/2002  | Compositions and Methods for Thermosetting Molecules in Organic Compositions | 011294/0174    | Pending |
| 09/587851        | 06/06/2000  | Low Dielectric Constant Nano Composites                                      | 011075/0072    | Issued  |
| 10/189318        | 07/03/2002  | Low Dielectric Constant Nano Composites                                      | 011075/0072    | Pending |
| Not Assigned Yet | 03/13/2003  | Low Dielectric Constant Nano Composites                                      | 011075/0072    | Pending |
| 09/792606        | 02/22/2001  | Porous Low Dielectric Constant Film Made Using Hollow Polymer Particles      | 011570/0776    | Allowed |

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| 10/339958  | 01/09/2003 | Porous Low Dielectric Constant Film Made Using Hollow Polymer Particles      | 011570/0776              | Pending |
| 09/671022  | 09/26/2000 | Reducing the Dielectric Constant of Flare Via Photogenerated Porosity        | 011184/0078              | Issued  |
| 09/619237  | 07/19/2000 | Low Dielectric Constant Materials With Polymeric Networks                    | 011235/0828              | Issued  |
| 10/004584  | 12/03/2001 | Low Dielectric Constant Materials With Polymeric Networks                    | 011235/0828              | Pending |
| 09/761529  | 01/11/2001 | Colloidal Silica Composite Films for Premetal Dielectric Applications        | 011876/0745              | Issued  |
| 10/188433  | 07/03/2002 | Colloidal Silica Composite Films for Premetal Dielectric Applications        | 011876/0745              | Pending |
| 09/825380  | 04/02/2001 | Smart Container for Bulk Delivery  | 011680/0042              | Pending |
| 10/263,204 | 10/01/2002 | Enhancement of Thermomechanical Properties                                   | Assignment not filed yet | Pending |
| 09/943237  | 08/29/2001 | CVD and Spin-On Process for Shallow Trench Isolation                         | 012146/0238              | Pending |
| 09/768439  | 01/23/2001 | Viscous Protective Overlayers For Planarization                              | 011904/0977              | Pending |
| 09/205006  | 12/02/1998 | Novolac Polymer Planarization Films With High Temperature Stability          | 9621/0857                | Issued  |
| 09/735838  | 12/12/2000 | Novolac Polymer Planarization Films With High Temperature Stability          | 9621/0857                | Issued  |
| 09/735746  | 12/12/2000 | Novolac Polymer Planarization Films With High Temperature Stability          | 9621/0857                | Allowed |
| 10/299127  | 12/18/2002 | Novolac Polymer Planarization Films With High Temperature Stability          | 9621/0857                | Pending |
| 09/227035  | 01/07/1999 | Dielectric Films From Organohydridosiloxane Resins With Low Organic Content  | 9698/0261                | Issued  |
| 09/609437  | 06/30/2000 | Dielectric Films From Organohydridosiloxane Resins With Low Organic Content  | 9698/0261                | Issued  |
| 09/227498  | 01/07/1999 | Dielectric Films From Organohydridosiloxane Resins With High Organic Content | 9699/0648                | Issued  |
| 09/609499  | 06/30/2000 | Dielectric Films From Organohydridosiloxane Resins With High Organic Content | 9699/0648                | Issued  |

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| 08/665189 | 06/14/1996 | Process for Making Hydroxy-Substituted Ethynylated Biphenyl Compounds                         | Assignment information not in file    | Issued  |
| 09/561387 | 04/27/2000 | Reactive Aqueous Metal Oxide Sols As Polishing Slurries for Low Dielectric Constant Materials | 010778/0978                           | Issued  |
| 10/214677 | 08/07/2002 | Reactive Aqueous Metal Oxide Sols As Polishing Slurries for Low Dielectric Constant Materials | 010778/0978                           | Pending |
| 09/235141 | 01/21/1999 | Solvent Systems For Low Dielectric Constant Polymeric Materials                               | 9907/0307                             | Issued  |
| 09/340976 | 06/28/1999 | Solvent Systems For Low Dielectric Constant Polymeric Materials                               | 9907/0307                             | Issued  |
| 10/143039 | 05/07/2002 | Solvent Systems For Low Dielectric Constant Polymeric Materials                               | 9907/0307                             | Issued  |
| 10/299320 | 11/18/2002 | Solvent Systems For Low Dielectric Constant Polymeric Materials                               | 9907/0307                             | Pending |
| 09/160514 | 09/24/1998 | Oxidizing Polishing Slurries For Low Dielectric Constant Materials                            | 9813/0001                             | Issued  |
| 09/882000 | 06/14/2001 | Oxidizing Polishing Slurries For Low Dielectric Constant Materials                            | 9813/0001                             | Pending |
| 08/665132 | 06/14/1996 | Poly (Arylene Ether) Compositions and the Method for Their Manufacture                        | 8190/0680                             | Issued  |
| 09/659380 | 09/08/2000 | Poly (Arylene Ether) Compositions and the Method for Their Manufacture                        | 8190/0680                             | Issued  |
| 08/271291 | 07/06/1994 | Novolac Polymer Planarization Films For Microelectronic Structures                            | 01024/0036                            | Issued  |
| 09/055516 | 04/06/1998 | Synthesis of Hydrogensilsesquioxane and Organohydridosiloxane Resins                          | Assignment not available at this time | Issued  |
| 09/698883 | 10/27/2000 | Spin-On Glass Anti-Reflective Coating For Photolithography                                    | 010245/0036                           | Issued  |
| 09/330248 | 11/13/2000 | Spin-On Glass Anti-Reflective Coating For Photolithography                                    | 010245/0036                           | Issued  |
| 10/012649 | 11/5/2001  | Spin-On Glass Anti-Reflective Coating For Photolithography                                    | 010245/0036                           | Pending |
| 10/001143 | 11/15/2001 | Spin-On Glass Anti-Reflective Coating For Photolithography                                    | 010245/0036                           | Pending |
| 09/491166 | 01/26/2000 | Spin-On Glass Anti-Reflective Coating For Photolithography                                    | 010245/0036                           | Issued  |
| 10/300357 | 11/19/2002 | Spin-On Glass Anti-Reflective Coating For Photolithography                                    | 010245/0036                           | Pending |

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| 10/076,846 | 02/14/2002 | Spin-On Glass Anti-Reflective Coating For Photolithography  | 010245/0036                           | Pending |
| 09/356487  | 07/19/1999 | Compositions and Processes For Spin Etch Planarization  | 010117/0691                           | Pending |
| 10/222230  | 08/15/2002 | Compositions and Processes For Spin Etch Planarization  | 010117/0691                           | Pending |
| 09/055244  | 04/06/1998 | Synthesis of Siloxane Resins  | Assignment not available at this time | Issued  |
| 09/505314  | 02/16/2000 | Synthesis of Siloxane Resins  | Assignment not available at this time | Pending |
| 09/745266  | 12/20/2000 | Composition for Chemical Mechanical Planarization of Copper, Tantalum, and Tantalum Nitride           | 010117/0800                           | Allowed |
| 09/357264  | 07/19/1999 | Composition for Chemical Mechanical Planarization of Copper, Tantalum, and Tantalum Nitride           | 010117/0800                           | Pending |
| 08/489424  | 06/12/1996 | Silicon Carboxide Composite Reinforced With Ceramic Fibers Having A Surface Enriched in Boron Nitride | Assignment not available at this time | Issued  |
| 09/590770  | 06/08/2000 | Chemical Hydrodynamic Etch Planarization  | 011980/0176                           | Pending |
| 09/547167  | 04/11/2000 | Use of Sacrificial Inorganic Dielectrics for Dual Damascene Processes. . .                            | 012734/0060                           | Pending |
| 09/390143  | 09/03/1999 | Photoresist Ashing Process for Organic and Inorganic Polymer. . .                                     | Assignment not available at this time | Issued  |
| 09/417257  | 10/12/1999 | Environment Controlled WIP Cart   | Assignment not available at this time | Issued  |
| 09/422039  | 10/20/1999 | Complex-Shaped Fiber for Particle and Molecular Filtration  | 010684/0327                           | Issued  |
| 09/833276  | 04/11/2001 | Devices and Methods for Chemical Reactive Filtration  | 011792/0556                           | Pending |
| 09/834581  | 04/12/2001 | Devices and Methods for Chemical Reactive Filtration  | 012266/0121                           | Pending |
| 09/617365  | 07/17/2000 | Absorbing Compounds for Spin-On-Glass Anti-Reflective Coatings for Photolithography                   | Assignment not available at this time | Issued  |
| 10/012651  | 11/05/2001 | Absorbing Compounds for Spin-   | Assignment not                        | Allowed |

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|-------------------------|------------|--|---------------------------------------|---------|
|                         |            | On-Glass Anti-Reflective Coatings for Photolithography                           | available at this time                |         |
| 09/547187               | 04/11/2000 | Chemical Mechanical Planarization of Low Dielectric Constant Materials           | 010757/0060                           | Issued  |
| 10/145649               | 05/14/2002 | Chemical Mechanical Planarization of Low Dielectric Constant Materials           | 010757/0060                           | Pending |
| 09/591181               | 06/08/2000 | Edge Bead Removal for Spin-On Materials. . .                                     | 011184/0225                           | Allowed |
| Serial No. Not Assigned | 02/26/2003 | Edge Bead Removal for Spin-On Materials. . .                                     | 011184/0225                           | Pending |
| 09/420218               | 10/18/1999 | Deposition of Organosilsesquioxane Films   | Assignment not available at this time | Issued  |
| 10/150185               | 05/16/2002 | Deposition of Organosilsesquioxane Films   | Assignment not available at this time | Pending |
| 09/420052               | 10/18/1999 | Deposition of Fluorosilsesquioxane Films   | Assignment not available at this time | Issued  |
| 10/150445               | 5/16/2002  | Deposition of Fluorosilsesquioxane Films   | Assignment not available at this time | Pending |
| 09/197478               | 11/20/1998 | Poly (Arylene Ether) Homopolymer Compositions and Methods of Manufacture Thereof | 9747/0690                             | Issued  |
| 09/039289               | 3/12/1998  | Stable Inorganic Polymers  | 9106/0106                             | Issued  |
| 09/044831               | 04/21/1997 | Organohydridosiloxane Resins With Low Organic Content                            | Assignment not available at this time | Issued  |
| 09/610567               | 07/03/2000 | Organohydridosiloxane Resins With Low Organic Content                            | Assignment not available at this time | Issued  |
| 09/044798               | 03/19/1998 | Organohydridosiloxane Resins With High Organic Content                           | 9067/0165                             | Issued  |
| 09/611528               | 06/30/2000 | Organohydridosiloxane Resins With High Organic Content                           | 9067/0165                             | Issued  |
| 10/299349               | 11/18/2002 | Organohydridosiloxane Resins With High Organic Content                           | 9067/0165                             | Pending |
| 08/990157               | 12/12/1997 | Poly (Arylene Ether) Compositions and Methods of Manufacture Thereof             | 9635/0730                             | Issued  |
| 09/847766               | 05/01/2001 | Spin-On Planarizers and Metallic Solder Planarizers for SEP                      | Assignment not available at this time | Pending |

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|-----------|------------|---|---------------------------------------|---------|
| 09/327356 | 06/07/1999 | Low Dielectric Constant Polyorganosilicon Coatings Generated From Polycarbosilanes  | 011838/0670                           | Issued  |
| 09/746607 | 12/20/2000 | Low Dielectric Constant Polyorganosilicon Coatings Generated From Polycarbosilanes  | 011838/0670                           | Issued  |
| 10/122400 | 04/11/2002 | Low Dielectric Constant Polyorganosilicon Coatings Generated From Polycarbosilanes  | 011838/0670                           | Pending |
| 09/471299 | 12/23/1999 | Hydridopolycarbosilane  | 010467/0172                           | Allowed |
| 10/163144 | 06/04/2002 | Hydridopolycarbosilane  | 010467/0172                           | Pending |
| 09/420091 | 10/18/1999 | Solvents for Processing Silsesquioxane and Siloxane Resins                          | Assignment not available at this time | Issued  |
| 09/145921 | 09/03/1998 | Method for Cleaning Organic Dielectric Film Containing Semiconductor Wafers         | 944/0152                              | Issued  |
| 09/538276 | 03/30/2000 | Nanoporous Polymers Having Backbones With Reactive Groups Employed In Cross-Linking | 010724/0678                           | Issued  |
| 09/544722 | 04/06/2000 | Nanoporous Polymers Crosslinked Via Cyclic Structures                               | Assignment not available at this time | Issued  |
| 09/544723 | 04/06/2000 | Nanoporous Material Fabricated Using Polymeric Template Strands                     | Assignment not available at this time | Issued  |
| 09/544504 | 04/06/2000 | Nanoporous Polymers Comprising Macrocycles  | 010723/0363                           | Issued  |
| 09/420611 | 10/18/1999 | Nanoporous Material Fabricated Using A Dissolvable Phase                            | Assignment not available at this time | Issued  |
| 09/420042 | 10/18/1999 | Infiltrated Nanoporous Materials and Methods of Producing The Same                  | Assignment not available at this time | Issued  |
| 09/651396 | 08/29/2000 | Infiltrated Nanoporous Materials and Methods of Producing Same                      | Assignment not available at this time | Pending |
| 09/512971 | 02/24/2000 | Alignment Plate with Matched Thermal Coefficient of Expansion                       | 010640/0663                           | Allowed |
| 10/238800 | 09/09/2002 | Alignment Plate with Matched Thermal Coefficient of Expansion                       | 010640/0663                           | Pending |

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